



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 20, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

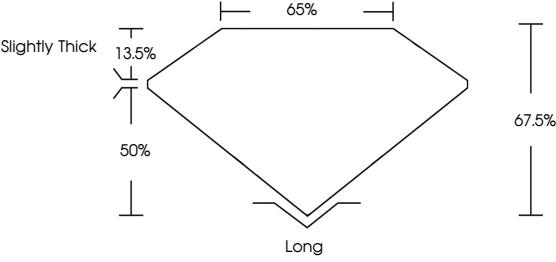
Inscription(s)

Comments: As Grown - No indication of post-growth treatment.
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

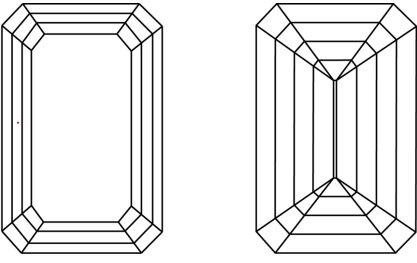
LG792645159

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY



Sample Image Used

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LABORATORY GROWN DIAMOND

EMERALD CUT

21.93 X 14.26 X 9.63 MM

30.68 CARATS

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

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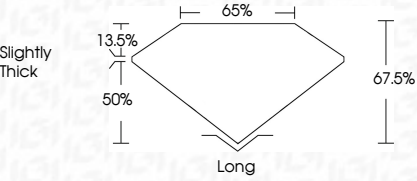
EXCELLENT

EXCELLENT

NONE

LG792645159

PROPORTIONS



IGI



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April 20, 2026

IGI Report No LG792645159

EMERALD CUT

21.93 X 14.26 X 9.63 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Graile

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

30.68 CARATS

D

VVS 1

67.5%

65%

Slightly Thick

Long

EXCELLENT

EXCELLENT

NONE

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